## In the Claims:

- 1-25. (cancelled)
- 26-27. (withdrawn)
- 28. (new) A probe-comb apparatus comprising:
- a two-metal probe-needle having a first tip-end and a second end;
- a film segment having a second surface and a first surface to which the probe-needle is attached and wherein the tip-end extends beyond an edge of the film.
- 29. (new) The apparatus in claim 28 wherein said tip-end comprises a noble metal.
- 30. (new) The apparatus in claim 29 wherein said noble metal is selected from the group consisting of palladium, rhodium, and gold.
- 31. (new) The apparatus in claim 29 wherein said tip-end comprises a metal and a noble metal deposited thereon.
- 32. (new) The apparatus in claim 28 wherein said tip-end is between 0.00075 and 0.0015 inches thick.
- 33. (new) The apparatus in claim 28 wherein said tip-end is at least 0.05 inches long.
- 34. (new) The apparatus in claim 28 wherein the tip-end is between 0.00075 and 0.002 inches wide.
- 35. (new) The apparatus in claim 28 wherein a second probe-needle is attached on the film segment.
- 36. (new) The apparatus in claim 28 wherein said film is a thermally stable, dielectric, polymeric material.
- 37. (new) The apparatus in claim 28 wherein said film is between 0.001 and 0.003 inches thick.
- 38. (new) The apparatus in claim 28 wherein said film comprises polyimide.
- 39. (new) The apparatus in claim 28 wherein said probe-needle is formed to optimize its electrical impedance.
- 40. (new) The apparatus in claim 28 further including a ground plane patterned on the second surface of said film.

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41. (new) The apparatus in claim 28 wherein the probe-needle is patterned with the aid of a computer and is formed by a laser.

42. (new) The apparatus in claim 28 wherein the probe-needle is at least partially formed by laser ablation.

43. (new) A probe card apparatus comprising:

a support block having a curved surface, a bottom surface, an outer perimeter, and an opening in the center;

a two-metal probe-needle;

- a film segment to which the probe-needle is attached and wherein a tip-end of the needle extends beyond an edge of the film.
- 44. (new) The apparatus in claim 43 wherein said tip-end of the needle extends beyond the bottom surface of the central opening in the support block.
- 45. (new) The apparatus in claim 43 wherein said support block comprises a dielectric material having a coefficient of thermal expansion between 2 and 8 PPM.
- 46. (new) The apparatus in claim 43 wherein said support block comprises a ceramic material.
- 47. (new) The apparatus in claim 43 wherein said support block comprises a composite polymer.
- 48. (new) The apparatus in claim 43 wherein said the outer perimeter of said support block conforms to an opening in a probe card.

## 49. (new) A probe card apparatus comprising:

a support block having a curved surface, a bottom surface, an outer perimeter, and an opening in the center;

- a two-metal probe-needle;
- a film segment to which the probe-needle is attached and wherein a tip-end of the needle extends beyond an edge of the film; and
- a probe card having an opening fitted to said support block perimeter and a conductive trace adapted to contact said probe-needle.

Respectfully submitted,

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